

Form PTO-1449

# INFORMATION DISCLOSURE CITATION IN AN APPLICATION

(Use several sheets if necessary)

 ATTY DOCKET NO.  
20-4652P

 APPLICATION NO.  
09/471,173

 APPLICANT  
Narihiro MOROSAWA et al.

 FILING DATE  
December 22, 1999

 GROUP  
Not Assigned

## U.S. PATENT DOCUMENTS

EXAMINER INITIAL	DOCUMENT NUMBER	DATE	NAME	CLASS	SUB CLASS	FILING DATE IF APPROPRIATE

## FOREIGN PATENT DOCUMENTS

	DOCUMENT NUMBER	DATE	COUNTRY	CLASS	SUB CLASS	TRANSLATION	
						YES	NO
72	HEI 5-082777 Japanese Patent Laid-Open Publication	4/2/93	JAPAN			ABST.	
72	HEI 5-074762 Japanese Patent Laid-Open Publication	3/26/93	JAPAN			ABST.	
72	HEI 5-283679 Japanese Patent Laid-Open Publication	10/29/93	JAPAN			ABST.	

## OTHER DOCUMENTS (Including Author, Title, Date, Pertinent Pages, etc.)

72	"Effects of boron penetration and resultant limitations in ultra thin pure-oxide and nitrided-oxide gate-films", Toyota Morimoto et al., <u>IEDM</u> , pp. 429-432, 1990.
72	"CMOS Technology Scaling, 0.1 $\mu$ m And Beyond", Bijan Davari, <u>IEDM</u> , pp. 555-558, 1996.
72	"Analysis of an ONO gate film effect on n- and p-MOSFET mobilities", H. Iwai et al., <u>1990 Symposium on VLSI Technology</u> , pp. 131-132.
72	"Hot-Electron Hardened Si-Gate MOSFET Utilizing F Implantation", Yasuhiro Nishioka, et al., <u>IEEE Electron Device Letters</u> , Vo. 10, No. 4, pp. 141-143, April 1989.

EXAMINER

Kevin Quinfa

DATE CONSIDERED

3/82/01

EXAMINER: Initial if citation considered, whether or not citation is in conformance with M.P.E.P. 609; Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.

TCB/AJT:kna

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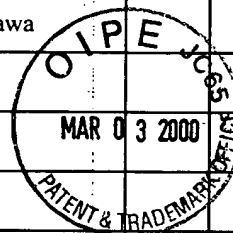
December 23, 1999

GROUP

2811

## U.S. PATENT DOCUMENTS

EXAMINER INITIAL	DOCUMENT NUMBER	DATE	NAME	CLASS	SUB CLASS	FILING DATE IF APPROPRIATE
92	6,018,182	01/25/2000	Morosawa			



## FOREIGN PATENT DOCUMENTS

	DOCUMENT NUMBER	DATE	COUNTRY	CLASS	SUB CLASS	TRANSLATION	
						YES	NO

## OTHER DOCUMENTS (Including Author, Title, Date, Pertinent Pages, etc.)


EXAMINER

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